

Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.  
MI22-1372

SERIAL NO.  
09/927,230

APPLICANT  
Truong Tri Doan

FILING DATE  
August 9, 2001

GROUP  
1762

LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
	AA 6,479,902	11/2002	Lopatin et al			
	AB 6,458,416	10/2002	Derderian et al			
	AC 6,368,954	04/2002	Lopatin et al			
	AD <del>6,235,571</del>	05/2001	Doan			
	AE 6,066,358	05/2000	Guo			
	AF 5,366,953	11/1994	Char et al			
	AG 5,273,930	12/1993	Steele et al			
	AH 6,114,099	09/2000	Liu et al			
	AI 2002/0125516	09/2002	Marsh et al			
	AJ					
	AK					

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
AL							
AM							
AN							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

AO		
AP		
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EV085426511

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ATTY. DOCKET NO. MI22-1372  
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APPLICANT Trung Thi Doan

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U.S. PATENT DOCUMENTS

*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filed in Appropriate
AA	4,913,090	04/1990	Harada et al			
AB	6,307,184	10/2001	Womack et al			
AC	5,616,208	04/1997	Lee			
AD	<del>6,200,000</del> 6,203,619	03/2001	McMillan			
AE	5,462,603	10/1995	Murakami			
AF	6,399,921	06/2002	Johnsgard et al			
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AJ	6,139,695	10/2000	Washburn et al			
AK	6,335,561	03/2002	Sandhu et al			
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FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Subclass	Translation	
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AP	Aarik, et al, "Control of Thin Film Structure by Reactant Pressure in Atomic Layer Deposition of TiO <sub>2</sub> ", Journal of Crystal Growth, 169 (1996) pgs. 496-502
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